

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Kun Li et al.  
Serial No.: 10/523,777  
Filed: August 28, 2003  
Art Unit: 2825  
Confirmation No.: 5732  
Examiner: Steven R. Garland  
Title: **METHOD AND SYSTEM FOR DYNAMIC MODELING AND  
RECIPE OPTIMIZATION OF SEMICONDUCTOR ETCH  
PROCESSES**  
Atty. Docket: VOY-007US

Cincinnati, Ohio

November 14, 2006

VIA ELECTRONIC TRANSMISSION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**ISSUE FEE**  
**CERTIFICATE OF ELECTRONIC TRANSMISSION**

I hereby certify that this correspondence for Application No. 10/523,777 is being electronically transmitted to Technology Center 3733, via EFS-WEB, on November 14, 2006.

By Joseph R. Jordan/  
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November 14, 2006  
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